

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Please enter.  
/Sikyln Ip/ 04/19/2010

Application No.	:	10/549,440	Confirmation No. 5587
Applicant	:	Takeo Okabe	
371 Filed	:	September 16, 2005	
Art Unit	:	1793	
Examiner	:	Sikyln Ip	
Customer No.	:	00270	
Title	:	COPPER ALLOY SPUTTERING TARGET, PROCESS FOR PRODUCING THE SAME AND SEMICONDUCTOR ELEMENT WIRING	

Mail Stop Amendment AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL**

Sir:

This is an Amendment After Final submitted in response to a FINAL Office Action dated January 25, 2010. No new issues are raised in this Amendment After Final. Kindly amend the application as set forth below.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.